

4319.7002



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shin Ohnuki

) I hereby certify that this paper is being deposited with the
United States Postal Service as FIRST-CLASS mail in an
envelope addressed to: Mail Stop AF, Commissioner for
Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this
date.

Serial No.: 10/796,344

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Joseph P. Fox
Registration No. 41,760
Attorney for Applicant(s)

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Date
F-CLASS.WCM
Appr. February 20, 1998

For: VACUUM PROCESSING
APPARATUS

Art Unit: 1763

Examiner: Lund, Jeffrie Robert

AMENDMENT B

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed May 31, 2006, please amend
the application as follows: